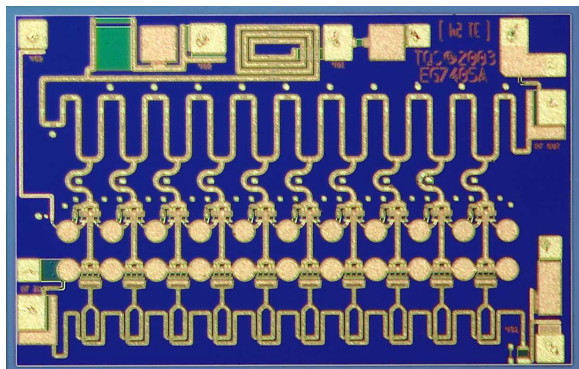


## Wideband LNA



### Key Features

- Frequency Range: 2-23 GHz
- 17 dB Nominal Gain
- 16 dBm Nominal P1dB
- < 2 dB Midband Noise Figure
- 0.15  $\mu$ m 3MI pHEMT Technology
- Nominal Bias:  $V_d = 5V$ ,  $I_d = 75$  mA
- Chip Dimensions: 2.09 x 1.35 x 0.10 mm  
(0.082 x 0.053 x 0.004 in)

### Primary Applications

- Wideband Gain Block / LNA
- X-Ku Point to Point Radio
- IF & LO Buffer Applications

### Product Description

The TriQuint TGA2513 is a compact LNA/Gain Block MMIC. The LNA operates from 2-23 GHz and is designed using TriQuint's proven standard 0.15  $\mu$ m gate pHEMT production process.

The TGA2513 provides a nominal 16 dBm of output power at 1 dB gain compression with a small signal gain of 17 dB. Typical noise figure is < 3 dB from 2-18 GHz.

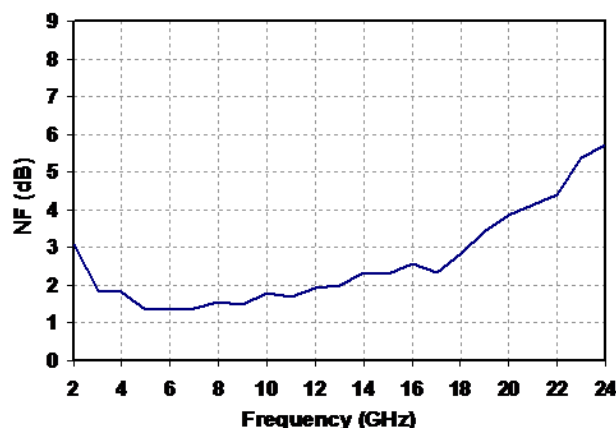
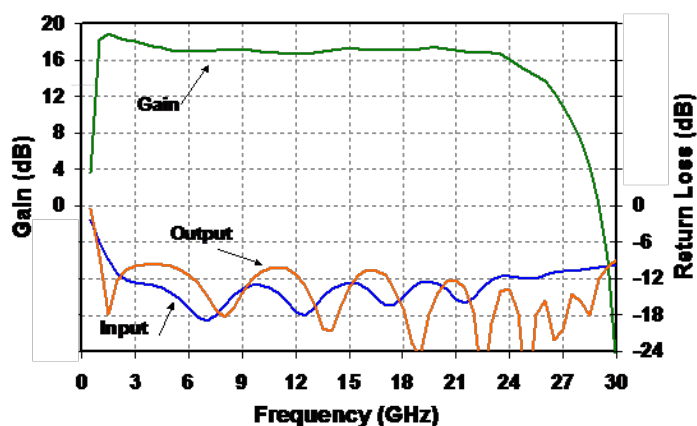
The TGA2513 is suitable for a variety of wideband electronic warfare systems such as radar warning receivers, electronic counter measures, decoys, jammers and phased array systems.

The TGA2513 is 100% DC and RF tested on-wafer to ensure performance compliance.

Lead-Free & RoHS compliant.  
Evaluation Boards are available upon request.

### Measured Fixtured Data

$V_d = 5V$ ,  $I_d = 75mA$ ,  $V_{g2} = 2V$ , Typical  $V_{g1} = -60mV$



**TABLE I**  
**MAXIMUM RATINGS 1/**

SYMBOL	PARAMETER	VALUE	NOTES
V <sub>d</sub>	Positive Supply Voltage	5 V	<u>2/</u>
V <sub>g1</sub>	Gate 1 Supply Voltage Range	-1V to 0 V	
V <sub>g2</sub>	Gate 2 Supply Voltage Range	(V <sub>d</sub> – 3) to (V <sub>d</sub> – 2) V	
I <sub>d</sub>	Positive Supply Current	151 mA	<u>2/</u>
I <sub>G</sub>	Gate Supply Current	10 mA	
P <sub>IN</sub>	Input Continuous Wave Power	21 dBm	<u>2/</u>
P <sub>D</sub>	Power Dissipation	0.76 W	<u>2/</u> , <u>3/</u>
T <sub>CH</sub>	Operating Channel Temperature	200 °C	<u>4/</u>
	Mounting Temperature (30 Seconds)	320 °C	
T <sub>STG</sub>	Storage Temperature	-65 to 150 °C	

- 1/ These ratings represent the maximum operable values for this device.
- 2/ Combinations of supply voltage, supply current, input power, and output power shall not exceed P<sub>D</sub>.
- 3/ When operated at this power dissipation with a base plate temperature of 70 °C, the median life is 1 E+7 hours.
- 4/ Junction operating temperature will directly affect the device median time to failure (T<sub>m</sub>). For maximum life, it is recommended that junction temperatures be maintained at the lowest possible levels.

**TABLE II**  
**DC PROBE TEST**  
(T<sub>A</sub> = 25 °C, Nominal)

SYMBOL	PARAMETER	MINIMUM	MAXIMUM	UNIT
I <sub>dss</sub> , Q1- Q10	Saturated Drain Current	--	216	mA
V <sub>p</sub> , Q1-Q10	Pinch-off Voltage	-1	0	V
V <sub>BVGD</sub> , Q1-Q10	Breakdown Voltage Gate-Drain	-30	-7	V
V <sub>BVGS</sub> , Q1-Q10	Breakdown Voltage Gate-Source	-30	-5	V

Note: Q1-Q10 is a 720um size FET.

**TABLE III**  
**RF CHARACTERIZATION TABLE**  
 ( $T_A = 25\text{ }^{\circ}\text{C}$ , Nominal)  
 $V_d = 5\text{V}$ ,  $I_d = 75\text{ mA}$   $V_{g2} = 2\text{V}$

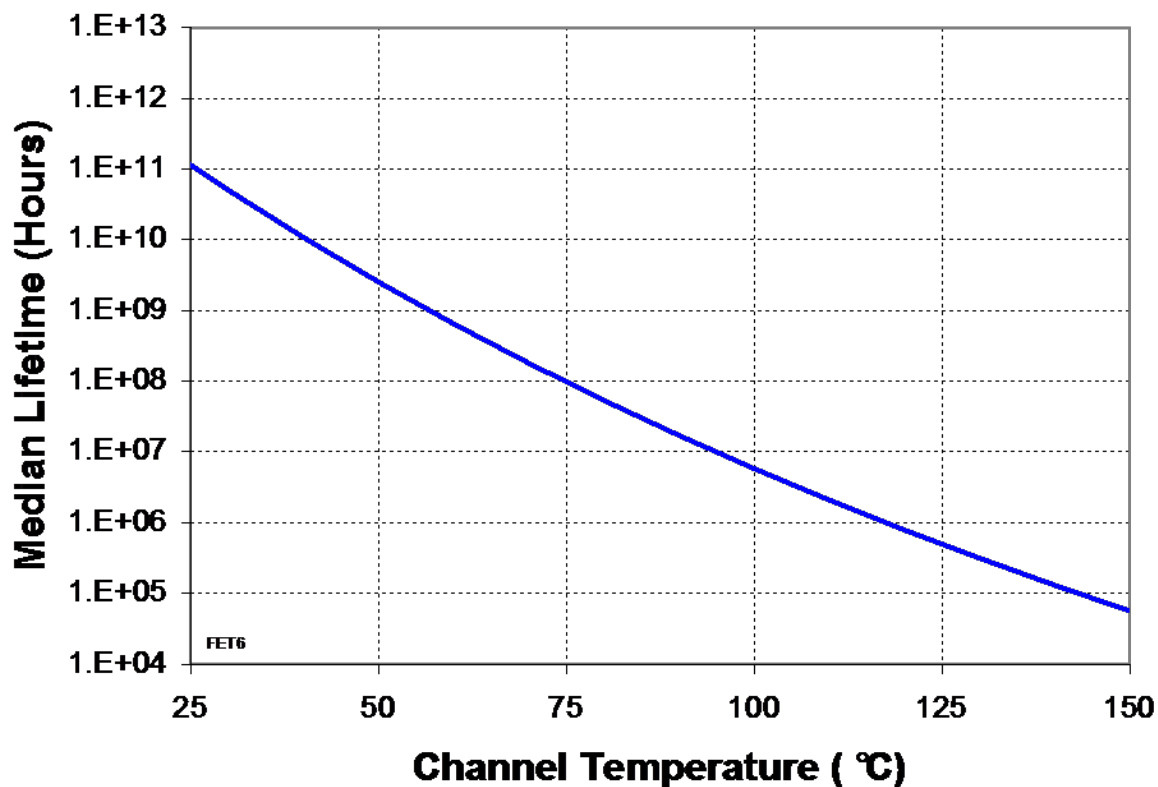
SYMBOL	PARAMETER	TEST CONDITION	NOMINAL	UNITS
Gain	Small Signal Gain	$f = 2\text{-}23\text{ GHz}$	17	dB
IRL	Input Return Loss	$f = 2\text{-}23\text{ GHz}$	14	dB
ORL	Output Return Loss	$f = 2\text{-}23\text{ GHz}$	14	dB
NF	Noise Figure	$f = 3\text{-}13\text{ GHz}$ $f = 2\text{-}18\text{ GHz}$	2 < 3	dB
$P_{1\text{dB}}$	Output Power @ 1dB Gain Compression	$f = 2\text{-}23\text{ GHz}$	16	dBm

**TABLE IV**  
**THERMAL INFORMATION**

Parameter	Test Conditions	T <sub>CH</sub> (°C)	θ <sub>JC</sub> (°C/W)	T <sub>m</sub> (HRS)
θ <sub>JC</sub> Thermal Resistance (channel to backside of carrier)	V <sub>d</sub> = 5 V I <sub>D</sub> = 75 mA P <sub>diss</sub> = 0.375 W	82	32	4.5 E+7

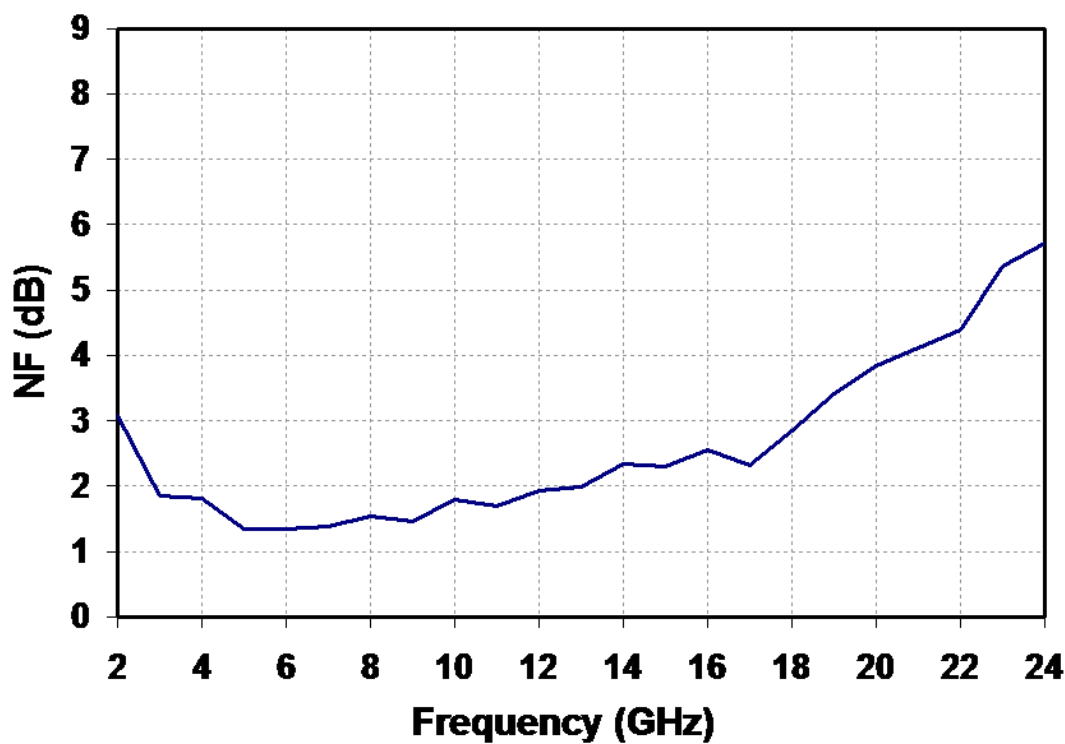
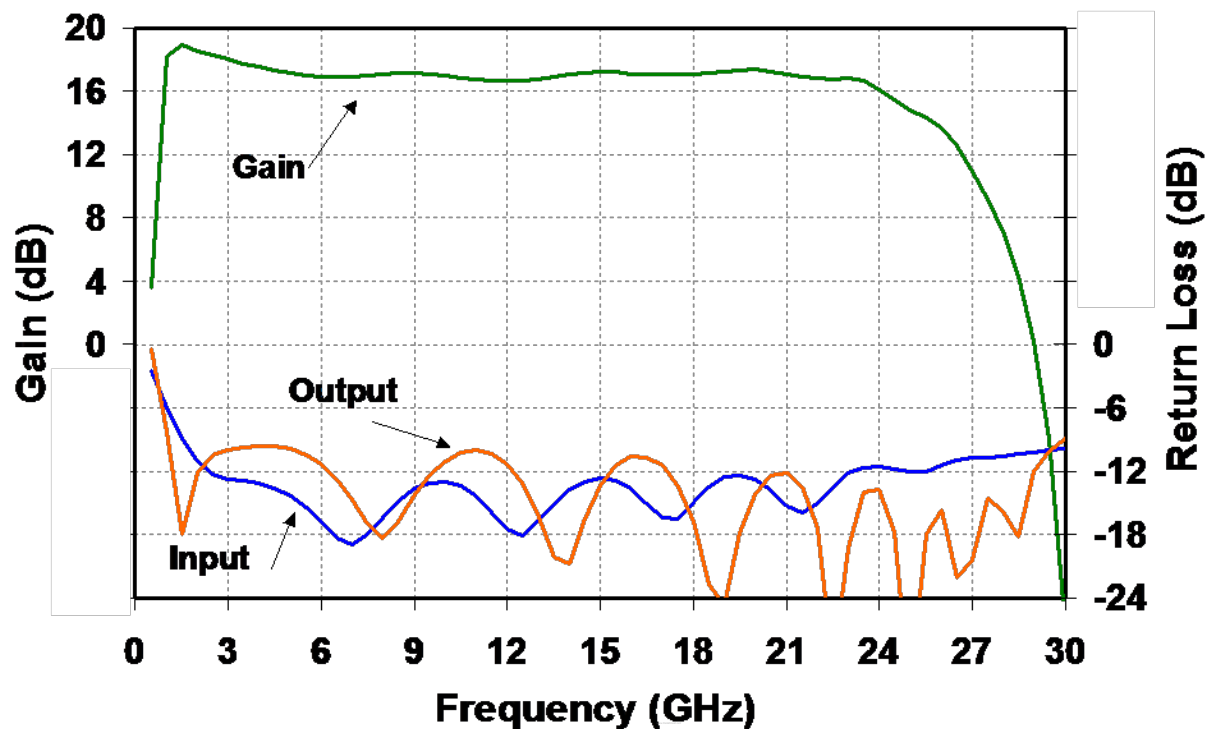
Note: Assumes eutectic attach using 1.5 mil 80/20 AuSn mounted to a 20 mil CuMo Carrier at 70°C baseplate temperature. Worst case condition with no RF applied, 100% of DC power is dissipated.

### Median Lifetime (T<sub>m</sub>) vs. Channel Temperature



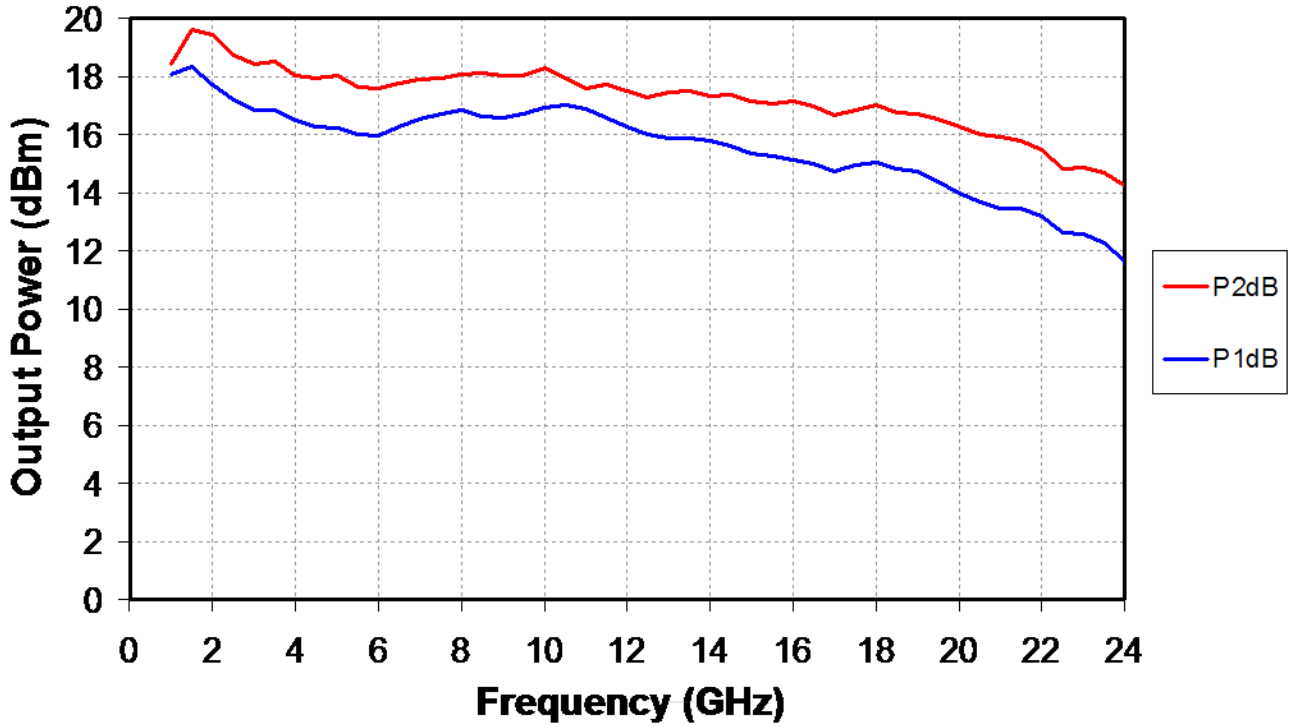
**Measured Fixtured Data**

**Vd = 5V, Id = 75mA, Typical Vg1 = -60mV, Vg2 = 2V**



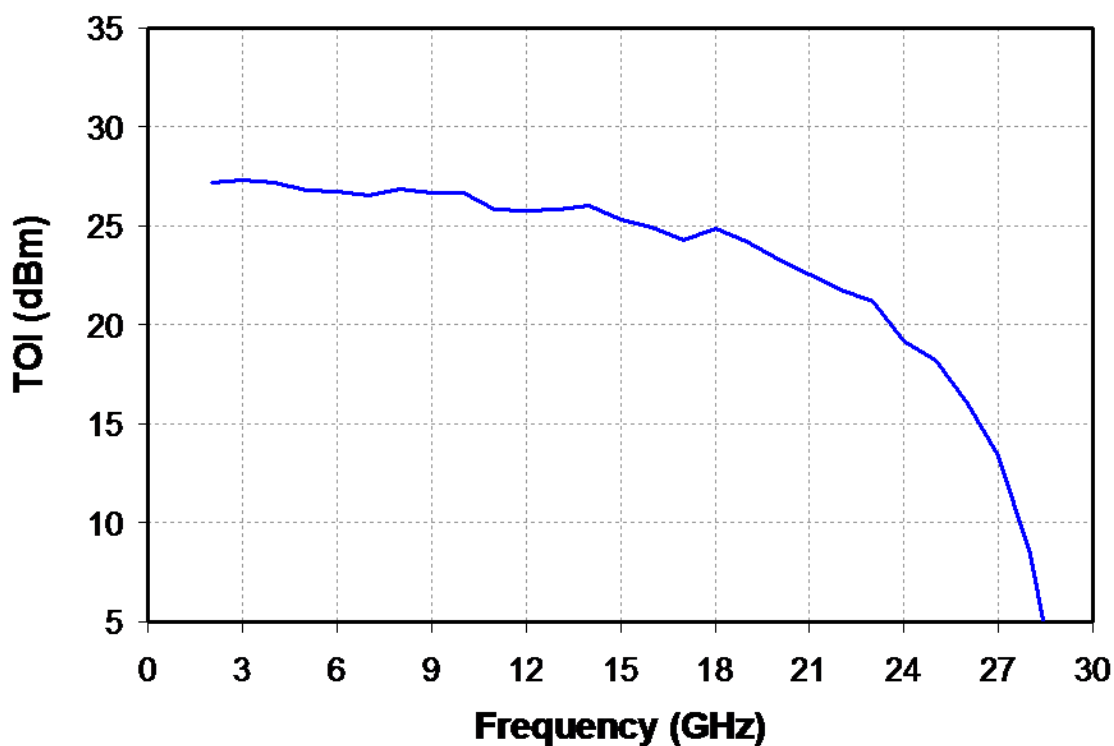
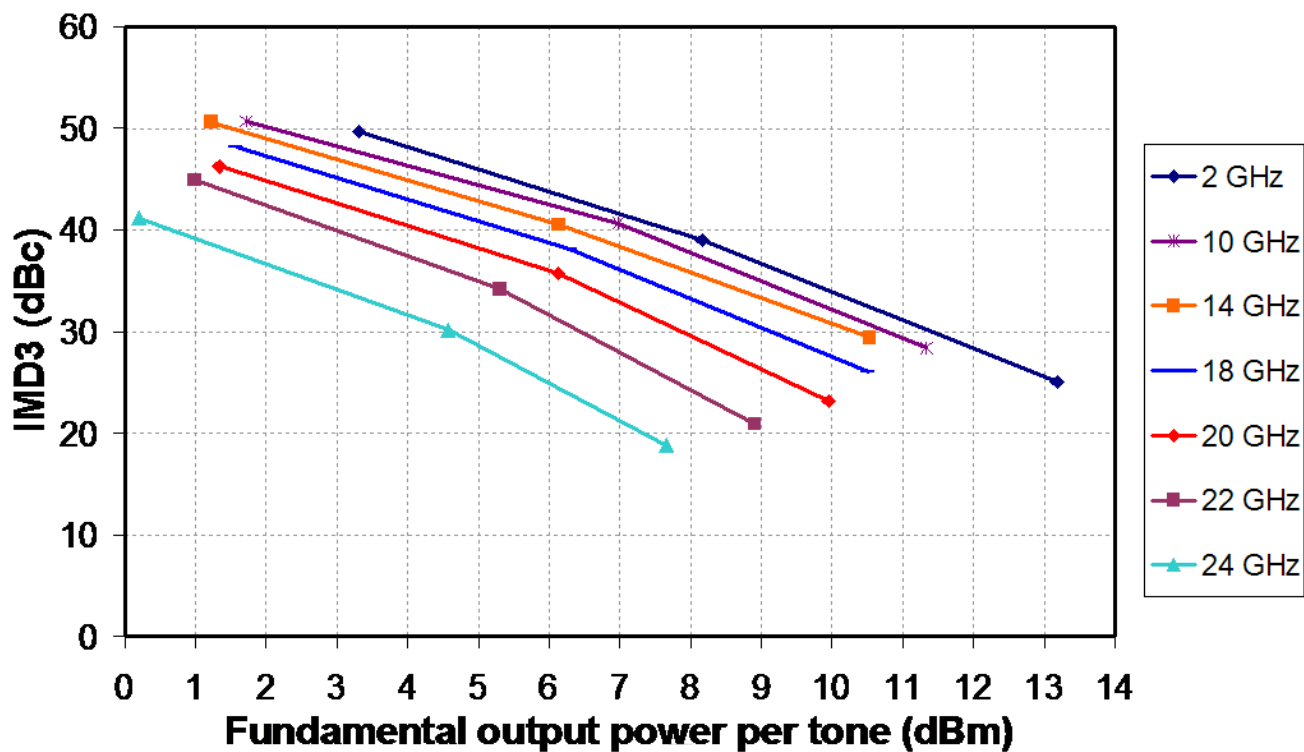
**Measured Fixtured Data**

**Vd = 5V, Id= 75mA, Typical Vg1 = -60mV,Vg2 = 2V**

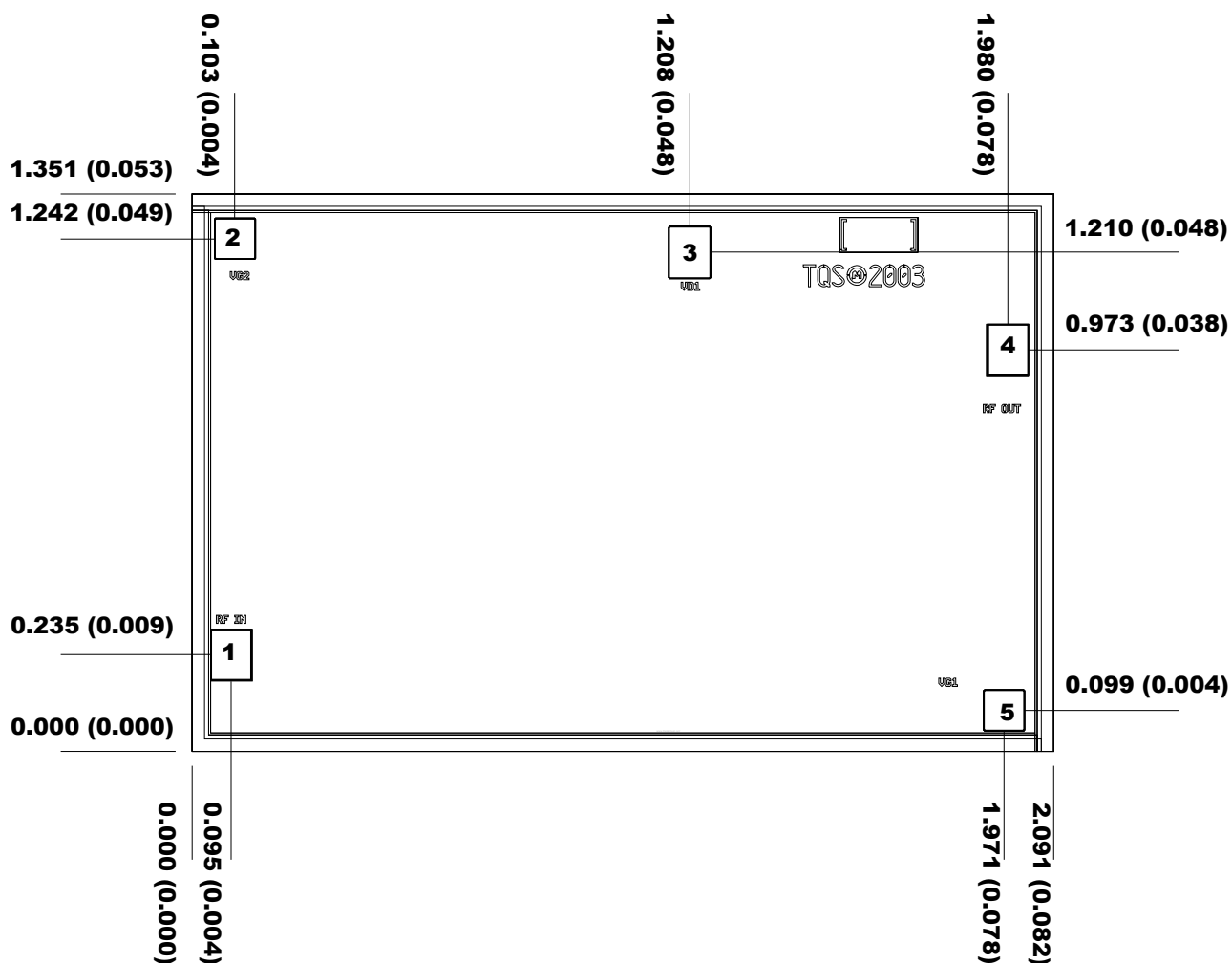


**Measured Fixtured Data**

**Vd = 5V, Id = 75mA, Typical Vg1 = -60mV, Vg2 = 2V**



## Mechanical Characteristics



**Units: millimeters (inches)**

**Thickness: 0.100 (0.004) (reference only)**

**Chip edge to bond pad dimensions are shown to center of pad**

**Chip size tolerance: +/- 0.051 (0.002)**

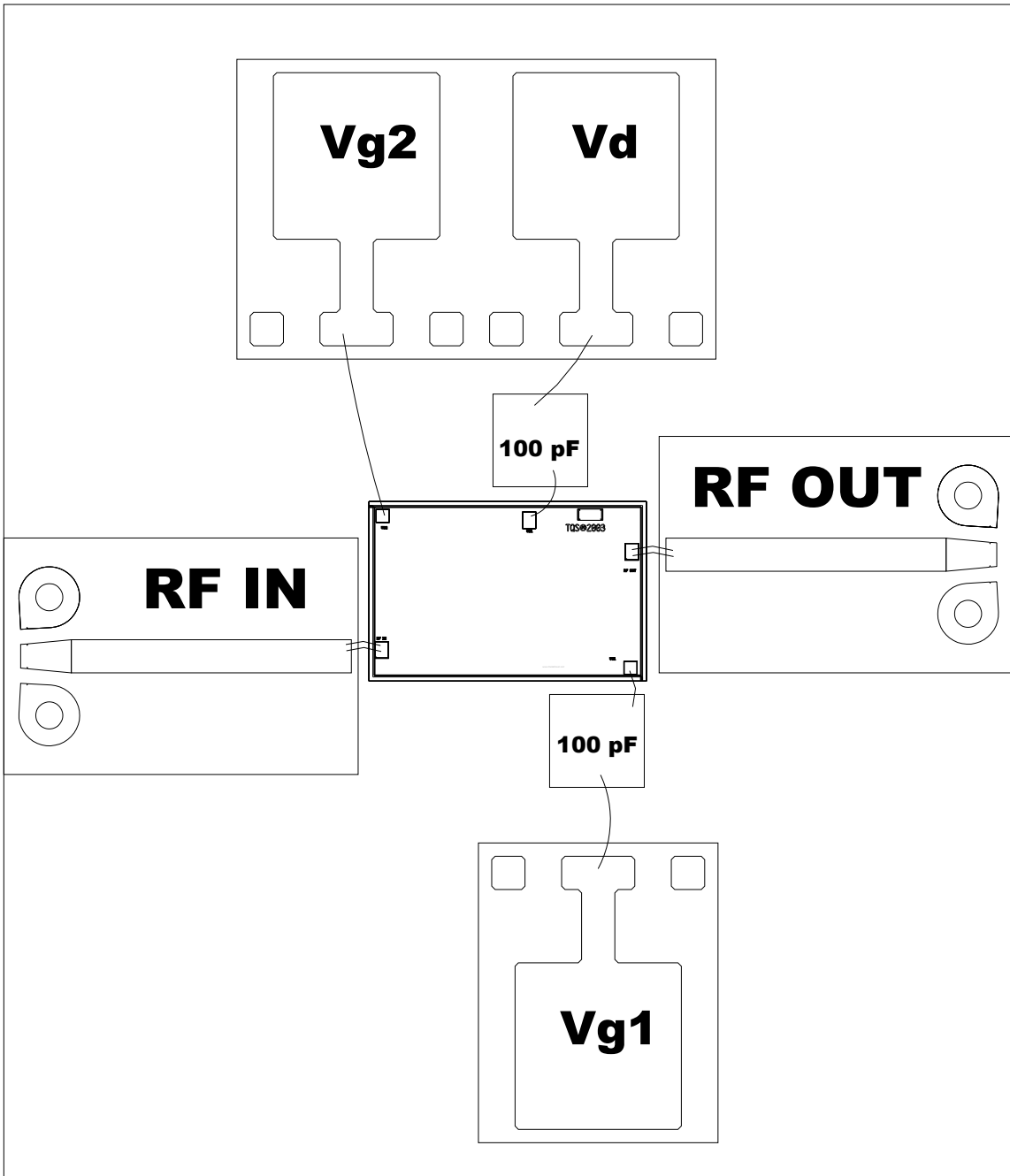
**GND IS BACKSIDE OF MMIC**

<b>Bond Pad #1:</b>	<b>RF IN</b>	<b>0.100 x 0.125 (0.004 x 0.005)</b>
<b>Bond Pad #2:</b>	<b>VG2</b>	<b>0.100 x 0.100 (0.004 x 0.004)</b>
<b>Bond Pad #3:</b>	<b>VD</b>	<b>0.100 x 0.125 (0.004 x 0.005)</b>
<b>Bond Pad #4:</b>	<b>RF OUT</b>	<b>0.100 x 0.125 (0.004 x 0.005)</b>
<b>Bond Pad #5:</b>	<b>VG1</b>	<b>0.100 x 0.100 (0.004 x 0.004)</b>

*GaAs MMIC devices are susceptible to damage from Electrostatic Discharge. Proper precautions should be observed during handling, assembly and test.*



**Recommended Assembly Diagram**



*GaAs MMIC devices are susceptible to damage from Electrostatic Discharge. Proper precautions should be observed during handling, assembly and test.*

## Assembly Process Notes

Reflow process assembly notes:

- Use AuSn (80/20) solder with limited exposure to temperatures at or above 300 °C for 30 sec
- An alloy station or conveyor furnace with reducing atmosphere should be used.
- No fluxes should be utilized.
- Coefficient of thermal expansion matching is critical for long-term reliability.
- Devices must be stored in a dry nitrogen atmosphere.

Component placement and adhesive attachment assembly notes:

- Vacuum pencils and/or vacuum collets are the preferred method of pick up.
- Air bridges must be avoided during placement.
- The force impact is critical during auto placement.
- Organic attachment can be used in low-power applications.
- Curing should be done in a convection oven; proper exhaust is a safety concern.
- Microwave or radiant curing should not be used because of differential heating.
- Coefficient of thermal expansion matching is critical.

Interconnect process assembly notes:

- Thermosonic ball bonding is the preferred interconnect technique.
- Force, time, and ultrasonics are critical parameters.
- Aluminum wire should not be used.
- Devices with small pad sizes should be bonded with 0.0007-inch wire.
- Maximum stage temperature is 200 °C.

***GaAs MMIC devices are susceptible to damage from Electrostatic Discharge. Proper precautions should be observed during handling, assembly and test.***